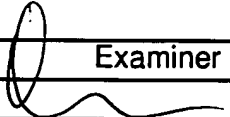


# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

<b>Title of Invention</b>	<b>A METHOD AND SYSTEM FOR FORMING A PASSIVATED METAL LAYER</b>						
<p>Application Number : 10/711717</p> <p>Confirmation Number: —</p> <p>First Named Applicant: Hideaki Yamasaki</p> <p>Attorney Docket Number: RAJ025</p> <p>Art Unit: 1762</p> <p>Examiner: —</p> <p>Search string: ( 6238737 ).pn</p>							
<b>US Patent Documents</b>							
<b>Note: Applicant is not required to submit a paper copy of cited US Patent Documents</b>							
<input checked="" type="checkbox"/>	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
<input checked="" type="checkbox"/>	1	6238737	2001-05-29	Chan et al.	B1	427	255.18
<b>Remarks</b>							
<p>Note: Remarks are not for responding to an office action.</p> <p>In accordance with the duty of candor and good faith imposed by 37 C.F.R. 1.56 and means of complying therewith according to 37 C.F.R. 1.97 and 1.98, the references listed on this Information Disclosure Statement are called to the attention of the United States Patent and Trademark Office in connection with the above-identified patent application. No representation is made that the cited art is the only art or that the cited art represents the best art. The Examiner is urged to consider all of the cited documents and to make an independent evaluation of the teachings and materiality of each. If any additional fees are necessary to complete this communication, please apply them to Deposit Account No. 23-3000.</p>							
<b>Signature</b>							
				Date			
				9/26/05			